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PATENT
P114-US

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I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail on January 30, 2003 in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231.

Patti Crowder
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of: Mathieu et al.

Application No.: 09/527,931

Filing Date: March 17, 2000

For: Method And Apparatus For Burning-In
Semiconductor Devices In Wafer Form

Examiner: R. Chang

Group Art Unit: 3919

NOTICE OF RELATED PATENT

Jan 30, 2003

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Applicants wish to draw the Examiner's attention to the following commonly owned patent (and the art cited therein), whose subject matter may be deemed related to the subject matter of the above-identified application.

US pat. no.: 6,509,751 (P101-US) issued January 21, 2003

Respectfully submitted,

Date: January 30, 2003

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